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WHAT IS CLAIMED IS:

1. A ESD protection structure having a single erystal Si-sided diode used to protect an internal circuit, the ESD protection structure electrically connected between an input pad and a node and the internal circuit electrically connected to the node, the ESD protection structure comprising:

a single crystal Si resistor formed over an insulating material layer, electrically coupled between the input pad and the rode; and

at least a single crystal silicon-sided junction diode formed over the insulating material layer, wherein each of the diodes is electrically coupled between one terminal of a corresponding power supply and a node.

- 2. The structure according to claim 1, wherein the insulating material layer is made of oxide.
- 3. The structure according to claim 1, wherein the insulating material layer includes a SOI.
- 4. The structure according to claim 1, further comprising an input buffer electrically coupled between the node and the internal circuit.
- 5. The structure according to claim 1, wherein the single crystal resistor is made of a single silicon layer on the insulating material layer.
- 6. The structure according to claim 1, wherein the single crystal Si-sided junction diode includes a P/N junction formed on the insulating material layer.
- 7. The structure according to claim 1, wherein the single crystal Si-sided junction diode includes a MOS transistor formed over the insulating material layer, and one of the source/drain/region of the MOS electrically connects to a gate by a wiring line.

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The structure according to claim 1, wherein the single crystal Si-sided junction diodes comprises:

a first diode, electrically connected between the node and one terminal of a first power supply; and

a second diode, electrically connected between the node and one terminal of a second power supply.

A ESD protection structure having a single crystal Si-sided diode used to protect an internal circuit formed from an insulating material layer on a SOI, the ESD protection structure electrically connected between an input pad and a node and the internal circuit electrically connected to the node, the ESD protection structure comprising:

an input resistor including a plurality of single resistors formed over the insulating material layer, wherein each of the single resistors is electrically coupled between the input pad and the node; and

at least a single crystal sided junction diode formed over the insulating material layer, wherein each of the diodes is electrically coupled between one terminal of a corresponding power supply and a node.

- The structure according to claim 9, further comprising an input buffer electrically coupled between the node and the internal circuit.
- The structure according to claim 9, wherein the single crystal resistor is made from a single silicon layer on the insulating material layer.
- The structure according to claim 9, wherein the single crystal Si-sided iunction diode includes a P/N jainction formed on the insulating material layer.

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13. The structure according to claim 9, wherein the single crystal Si-sided junction diode includes a MOS transistor formed over the insulating material layer, and one of the source/drain region of the MOS electrically connects to a gate by a wiring line.

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14. A semiconductor structure of ESD protection, the ESD protection electrically connects between an input pad and an integrated circuit, the semiconductor structure comprising:

a semiconductor substrate;

an insulating layer, formed on the semiconductor substrate;

at least a single crystal Si resistor, formed over the insulating layer;

at least a single crystal Si-sided junction diode, formed over the insulating layer;

a first conductive layer, formed over the insulating layer, used to electrically connect one terminal of the single crystal Si resistor and the input;

a second conductive layer, formed over the insulating layer, used to electrically connect another terminal of the single crystal Si resistor and the integrated circuit; and

a third conductive layer, formed over the insulating layer, used to connect the single crystal Si-sided junction diode and the integrated circuit.

15. The structure according to claim 14 wherein the single crystal Si resistor includes a single crystal silicon layer.

16. The structure according to claim 14, wherein the single crystal sided junction diode includes a single crystal siligon P/N junction.

17. The structure according to claim 14, wherein the single crystal Si-sided junction diode includes a MOS transistor, and one source/drain region of the MOS electrically connects to a gate by a wiring line.



- 18. The structure according to claim 14, wherein at least a single crystal Si resistor includes a plurality of single crystal Si resistors.
- 19. The structure according to claim 18, wherein the single crystal Si resistors are isolated by an isolation structure.
- 20. The structure according to claim 19, wherein the isolation structure includes a shallow trench isolation.

